



[20103 00201]

**POWER OF ATTORNEY BY ASSIGNEE OF ENTIRE INTEREST**

Sceptre Electronics Limited, as assignee of the entire right, title, and interest in the application for patent entitled **DEVICE FOR FORMING NANOSTRUCTURES ON THE SURFACE OF A SEMICONDUCTOR WAFER BY MEANS OF ION BEAMS**, filed February 25, 2002 and assigned Serial No. 10 069,656, hereby appoints Patrick J. Fay (Reg. No. 35,508) and Oleg F. Kaplun (Reg. No. 45,559) as its attorneys/agents with full power of substitution and revocation, to prosecute this application and to transact all business in the U.S. Patent and Trademark Office connected therewith.

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**Sceptre Electronics Limited**

Dated: 22/05/02

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